

<b>Notice of References Cited</b>	Application/Control No. 10/826,221	Applicant(s)/Patent Under Reexamination BERDAN, CLARKE	
	Examiner Daniel J. Colilla	Art Unit 2854	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2003/0091758	05-2003	Osumi et al.	428/34
	B	US-2003/0041962	03-2003	Johnson et al.	156/266
	C	US-4,801,495	01-1989	van der Hoeven, Johannes C. W.	442/412
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 2001232700 A	08-2001	Japan	KITAMURA et al.	B31D 01/02
	O	JP 2000318389 A	11-2000	Japan	HATORI, SHINICHI	B44C 01/165
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Machine translation of JP 2001232700 to Kitamura et al. from Japanese Patent Office website.
	V	Machine translation of JP 2000318389 to Hatori from Japanese Patent Office website.
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.